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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
TADAHIRO OHMI, ET AL. ) Examiner: A. Rodriguez  
Application No.: 09/531,958 ) Group Art Unit: 2828  
Filed: March 21, 2000 )  
For: LASER OSCILLATING )  
APPARATUS EXPOSURE )  
APPARATUS, AND DEVICE )  
FABRICATION METHOD ) Date: December 9, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CORRECTED REQUEST FOR CONSIDERATION OF  
INFORMATION DISCLOSURE STATEMENT

Sir:

A Request For Consideration Of Information Disclosure Statement was filed November 19, 2003 which referred to Information Disclosure Statements dated May 25, 2000 and August 9, 2003. The Information Disclosure Statements were in fact dated May 25, 2000 and October 9, 2003.

It is respectfully requested that the Examiner indicate that the art cited in these Information Disclosure Statements has been considered and made formally of record by initialing the Forms PTO-1449 that accompanied those Information Disclosure

Statements. Copies of the appropriate PTO-1449s are enclosed for the Examiner's convenience.

Applicants' undersigned attorney may be reached in our Costa Mesa, California office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



Michael K. Difur  
Attorney for Applicants

Registration No. 32,622

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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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